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CONFIRMATION NO. 4723

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10/595,686	12/27/2006 RULE	250	4181	1751-405

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**** CONTINUING DATA *******
 This application is a 371 of PCT/KR04/02866 11/06/2004

**** FOREIGN APPLICATIONS *******
 REPUBLIC OF KOREA 10-2003-0078244 11/06/2003

**** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** ** SMALL ENTITY ****
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Foreign Priority claimed 35 USC 119(a-d) conditions met	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No	<input type="checkbox"/> Met after Allowance	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWINGS 18	TOTAL CLAIMS 7	INDEPENDENT CLAIMS 2
Verified and Acknowledged	/REBECCA Y LEE/ Examiner's signature	Initials				

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TITLE
 Method for Forming ZnO Nano-Array and ZnO Nanowall for Uv Laser On Silicon Substrate

FILING FEE RECEIVED 515	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees
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